

Notice of References Cited	Application/Control No. 10/670,221	Applicant(s)/Patent Under Reexamination AHVONEN ET AL	
	Examiner Van Kim T. Nguyen	Art Unit 2661	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

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